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Facile synthesis of differently shaped, ultrathin, and aligned graphene flakes without a

catalyst for highly efficient field emission

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Abstract

Aligned graphene flakes (AGFs) were prepared on different substrates without a catalyst by using

radio frequency (rf) sputtering deposition. Their shapes can be readily controlled by adjusting

substrate temperatures and rf powers. Ultrathin AGFs (less than 5 layers) can only be prepared with

substrate temperatures higher than 1000 K, and AGFs grown at 1100 K are wrinkled graphenes. The

rf power controls the AGF shapes by means of hydrogen plasma etching, and the growth rate of

AGFs decreases with the increase of rf powers. The catalyst-free growth characteristic determines

that the growth of AGFs is substrate independent, but their ultimate shapes greatly depend on the

geometric configuration and surface topography of substrates due to the defect-guided nucleation of

AGFs. The field emission properties of differently shaped AGFs and AGF composites were

measured. Optimal field emission properties are obtained from AGF-Si nanowire composites. They

have an ultralow turn-on electric field of 1.80 V/µm, which for the as-grown Si nanowires is 7.33

V/μm, and also have excellent field emission stability after being perfectly aged. We consider that

both the nanosharp edges of AGFs and the high aspect ratios of Si nanowires are responsible for

this excellent field emission performance.

Keywords: graphene; radio frequency; catalyst-free; composites; field emission; defect

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